

SEMI® IMSG - Liaison Report - Japan

July 2004

SEMICON West 2004

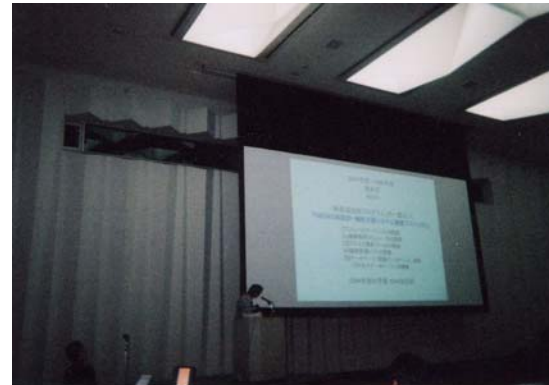


Seminar Plan

- Micromachine Seminar
 - June. Co-held event with SEMI Forum Japan at Osaka
 - Chair: Prof. Susumu Sugiyama / Ristumeikan Univ.
 - Focus on application
- Microsystem/MEMS Seminar
 - December Co-held event with SEMICON Japan at Makuhari
 - Chair: Prof. Masayoshi Esashi / Tohoku Univ.
 - Focus on Hot topics of MEMS industry + MEMS manufacturing technology

6th Micromachine Seminar Report

- Jun 16 Wed.
- Thema “PowerMEMS”
- 7 Speakers
- Total 110 Attendees
 - Accumulation of 6 years attendees are 580.
- 11 Table top exhibitors



8th Microsystem / MEMS Seminar Plan

- Thema “MEMS manufacturing technology”
 - New topics of Manufacturing
 - Consortium(Collaboration)/Micro Plating /
- Speakers
 - Dr. Luke P. Lee
 - Prof. Kazuo Kondo.....
- 150 target figures of attendees

8th Microsystem / MEMS Seminar Plan – Cont. -

- Collaboration with related events
 - DPS 2004 (International Symposium on Dry Process) Nov. 30 – Dec. 1 Tokyo
 - PowerMEMS 2004 Nov. 29 – 30 Kyoto
 - Speakers: invitation 2 presentation opportunity
 - Attendees: Participation with multi MEMS events during a week

Corporation with MEMS/NEMS pavilion

- SEMICON Japan 2004 MEMS/NEMS Pavilion
 - < 50 exhibitors.
 - Exhibit space application have been sent out at the end of April.
 - Three booth types.
 - Application Showcase
 - Academia exhibit space

Strong Collaboration with IEEJ (The Institute of Electrical Engineers of Japan)

- Most of Japanese IMSG members have membership of IEEJ
- Effective promotion opportunities for each organization
 - APCOTMNT(Asia Pacific Conference of Transducers and Micro-Nano Technology)
 - July 4-7 in Sapporo
 - The 21st Sensor Symposium on Sensors, Micromachines, and Applied Systems
 - Oct. 13 – 15 in Kyoto
 - Transducers05
 - Jun. 5 – 9 in Seoul

Additional topics

- MEMS Park Consortium
 - An industry-government-academia project
 - Sendai City, Tohoku University
 - MEMSCore, Advantest,
 - Oct. 19 Opening Ceremony